



**Patent**

Customer No.: 31561  
Docket No. 11760-US-PA  
**Application No.: 10/605,360**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : Lai  
Application No. : 10/605,360  
Filed : 2003/09/25  
For : METHOD FOR FABRICATING A MOSFET AND  
REDUCING LINE WIDTH OF GATE STRUCTURE  
Art Unit : 2825  
Examiner : KESHAVAN, BELUR V

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**TRANSMITTAL LETTER**

**002-1-703-872-9306**

**(Via fax: 14 pages, followed by confirmation copy via courier)**

Assistant Commissioner for Patents  
Arlington, Virginia 22202

In response to the Office Action dated March 29, 2004, please find the relevant paper in response to paper No. 03182004. Following the fax transmission, a hard copy via courier will also be forwarded to the Office.

Enclosed documents via courier will include:

- ☒ Amendment and Response to Office Action in (7) pages
- ☒ Amended Drawings in (5) pages
- ☒ Fax confirmation report
- ☒ Prepaid return postcard

I believe that no fee is incurred. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 11760-US-PA)

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

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Respectfully Submitted,  
JIANQ CHYUN Intellectual Property Office

Date: May 27, 2004

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